## Applicant(s)/Patent Under Application/Control No. Reexamination 10/807,364 LAI, HAN-CHUNG Notice of References Cited Art Unit Examiner Page 1 of 1 2871 Mike Qi **U.S. PATENT DOCUMENTS** Document Number Date Classification Name MM-YYYY Country Code-Number-Kind Code 438/4 02-1990 Muto, Ryujiro US-4,902,638 A Α \* 349/46 US-5,546,205 A 08-1996 Sukegawa et al. В \* 349/55 С US-5,995,178 A 11-1999 Fujikawa et al. \* 349/42 Ukita, Tooru US-6,310,668 B1 10-2001 D \* 349/43 Lee, Joun Ho US-2003/0016310 A1 01-2003 Ε US-F US-G US-Н USı

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